AFTER FINAL - EXPEDITED PROCEDURE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Takatoshi Tsujimura et al. Applicants:

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Forming a Thin Film Structure

Atty. Dkt. No.:

CMO.0012US (92096US)

Mail Stop AF Commissioner for Patents

· P.O. Box 1450

Alexandria, VA 22313-1450

REPLY TO OFFICE ACTION MAILED JANUARY 9, 2006

Dear Sir.

In response to the Office Action mailed January 9, 2006, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

عاده Date of Deposit

I hereby certify that this correspondence is being fluorimite transmitted to the U.S. Patent Office (Fax No. (571) 273-8300) on the

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